

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Goodman <i>et al.</i>
App. No	:	10/775,522
Filed	:	February 10, 2004
For	:	TWO-STAGE LOAD FOR PROCESSING BOTH SIDES OF A WAFER
Examiner	:	Sylvia MacArthur
Art Unit	:	1792
Conf No.	:	1057

RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated October 7, 2008, Applicants have timely filed this Response. Applicants respectfully request the Examiner to grant allowance of this application in view of the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.